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# Calendar

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To list an event in the Calendar, contact Julia Phillips, AT&T Bell Laboratories, 600 Mountain Avenue IE-431, Murray Hill, NJ 07974; telephone (201) 582-4428.

**MRS** indicates the meeting is sponsored by or affiliated with the Materials Research Society.

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## DECEMBER 1985

- 2-6 **MRS** Fall Meeting of the Materials Research Society. Boston, MA.  
J. B. Ballance,  
Materials Research Society,  
9800 McKnight Rd., Suite 327,  
Pittsburgh, PA 15237;  
(412) 367-3003.
- 18-20 Solid State Physics Conference. University of Reading. Inst. of Physics, 47 Belgrave Sq., London SW1X 8QX, U.K.; 01-235-6111

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## JANUARY 1986

- 19-24 Symposium on Optical and Electro-Optical Engineering. Los Angeles, CA.  
SPIE, P.O. Box 10, Bellingham, WA 98227-0010; (206) 676-3290.
- 27-28 Conference on III-V and II-VI Compound Semiconductor Surfaces: Structure, Composition, and Electrical Properties. Atlanta, GA.  
Microelectronics Research Center, Building 0250, GA Institute of Technology, Atlanta, GA 30332; (404) 894-2928.

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## FEBRUARY 1986

- 9-12 9th Annual Meeting of the Adhesion Society. Hilton Head, SC.  
J. P. Wightman, VPE, Chemistry Dept., Blacksburg, VA 24061; (703) 961-5854.

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## MARCH 1986

- 9-14 SPIE Symposium on Microlithography. Santa Clara, CA.  
SPIE Technical Program Committee, P.O. Box 10, Bellingham, WA 98227-0010; (206) 676-3290.
- 22-25 Conference of the Condensed Matter Division of the European Physical Society. Stockholm, Sweden.  
G. Grimvall, Dept. of Theoretical Physics, Royal Inst. of Technology, S-100 44 Stockholm, Sweden.
- 31-4 General Meeting of the APS. Las Vegas, CA.  
W. W. Havens, 335 E. 45th St., New York, NY 10017
- 31-5 Optical Society of America 1986 Spring Meeting. Honolulu, Hawaii.  
OSA, 1816 Jefferson Pl., N.W., Washington, DC 20036

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## APRIL 1986

- 6-11 International Conference on Metallurgical Coatings. San Diego, CA.  
H. A. Beale, Applied Coatings International, 775 Kaderly Dr., Columbus, OH 43228
- 7-10 **MRS** Low Energy Ion Beams—4. Brighton, England.  
The Institute of Physics, 47 Belgrave Square, London SW1X 8QX, England; 01-235-6111.  
*(See related article in Vol. X No. 5.)*
- 8-10 31st National SAMPE Symposium—Materials Science for the Future. Las Vegas, CA.  
Marge Smith, SAMPE, P.O. Box 2459, Covina, CA 91722; (818) 331-0616.

- 13-18 American Chemical Society General Meeting. New York, NY.  
American Chemical Society, 1155 16th St., N.W., Washington, DC 20036.
- 15-18 **MRS** Spring Meeting of the Materials Research Society. Palo Alto, CA.  
J. B. Ballance,  
Materials Research Society,  
9800 McKnight Rd., Suite 327,  
Pittsburgh, PA 15237;  
(412) 367-3003.
- 27-1 American Ceramic Society General Meeting. Chicago, IL.  
American Ceramic Society, 65 Ceramic Dr., Columbus, OH 43214.

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## MAY 1986

- 1-2 **MRS** Semiconductor Based Heterostructures: Interface Structure and Stability (1986 TMS Northeast Regional Conference). Murray Hill, NJ.  
Martin L. Green, AT&T Bell Laboratories, Murray Hill, NJ; (201) 582-3000.
- 4-9 Spring Meeting of the Electrochemical Society. Boston, MA.  
Electrochemical Society,  
10 S. Main St., Pennington, NJ 08534-2896.
- 4-9 Fifth International Symposium on Silicon Materials Science & Technology. Boston, MA.  
H. R. Huff, Monsanto Electronic Materials Company, 755 Page Mill Rd. P.O. Box 10123, Palo Alto, CA 94303
- 27-30 International Conference on Composite Interfaces. Cleveland, OH.  
H. Ishida, Dept. of Macromolecular Sci., Case Western Reserve Univ., Cleveland, OH 44106; (216) 368-4285.

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JUNE 1985

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- 9-13 **MRS International Conference on Ion Beam Modification of Materials.**  
Catania, Italy.  
E. Rimini, Depart. of Physics,  
Corso Italia 57, 195129 Catania,  
Italy.
- 9-13 OSA/IEEE Conference on Laser & Electro-Optics (CLEO '86).  
San Francisco, CA.  
Optical Society of America, 1816  
Jefferson Pl., N.W., Washington,  
DC 20036
- 9-13 International Conference on  
Quantum Electronics.  
San Francisco, CA.  
Optical Society of America, 1816  
Jefferson Pl., N.W., Washington,  
DC 20036;  
(202) 223-0920.
- 10-12 7th International SAMPE  
European Chapter Conference &  
Exhibition.  
Munich, Germany.  
SAMPE, 843 West Glentana (Box  
2459), Covina, CA 91722;  
(818) 331-0616  
*(See related article in Vol. X No. 5.)*

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JULY 1986

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- 7-11 Fifth International Conference on  
Surface Modification of Metals of  
Ion Beams.  
Kingston, Ontario.  
J. L. Whitton, Physics Dept.  
Queens Univ., Kingston, ONT  
K7L 3N6: (613) 547-2746.
- 28-31 International Conference on  
Ceramic Microstructures '86: Role  
of Interfaces.  
University of California, Berkeley,  
CA.  
Joseph A. Pask, Dept. of Materials  
Science and Mineral Engineering,  
University of California, Berkeley,  
CA; (415) 642-3801.
- 28-1 Second International Conference  
on Shallow Impurity Centres.  
Trieste, Italy.  
Prof. R. Resta, SISSA Strada  
Costiera 11, 34014 Trieste, Italy;  
telephone (040) 22 41 18; telex  
460392 ICTP I.

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AUGUST 1986

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- 10-13 International Conference on Low-  
Energy Dislocation Structures.  
Charlottesville, VA.  
D. Murdaugh, Dept. of  
Conferences & Institutes, Div. of  
Continuing Education, P.O. Box  
3697, 104 Midmont Ln.,  
Charlottesville, VA 22903; (804)  
924-7141.
- 11-15 18th International Conference on  
the Physics of Semiconductors.  
Stockholm, Sweden.  
S. T. Pantelides, ICPS-18 Program  
Subcommittee Chairman, IBM T.  
J. Watson Research Center, P.O.  
Box 218, Yorktown Heights, NY  
10598; (914) 945-3000.
- 17-22 30th Annual Symposium on  
Optical & Electro-Optical  
Engineering.  
San Diego, CA.  
SPIE, P.O. Box 10, Bellingham,  
WA 98227-0010; (206) 676-3290.
- 18-22 14th International Conference on  
Defects in Semiconductors.  
Paris, France.  
D. Stievenard, Secretary ICDS 14,  
ISEN, 3 rue Francois Baès, 59046,  
Lille, France.

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SEPTEMBER 1986

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- 7-10 International Conference on  
Molecular Beam Epitaxy.  
York, U.K.  
G. J. Davies, British Telecom  
Research Labs, Martlesham  
Heath, Ipswich IP5 7RE, U.K.
- 8-11 16th European Solid State Device  
Research Conference.  
Cambridge, UK.  
Meetings Officer,  
IOP, 47 Belgrave Sq.,  
London, UK SW1X 8QX.
- 14-19 Symposium on Optical & Electro-  
Optical Engineering.  
Cambridge, MA.  
SPIE, P.O. Box 10, Bellingham,  
WA 98227-0010.
- 22-27 Eighth International Congress on  
the Chemistry of Cement.  
Rio de Janeiro, Brazil.  
Secretaria Geral-8° Cong. Int. de  
Quim. do Cimento, Rua da  
Assembléia, 10, 40° Andar, Grupo  
4001, 20.011, Rio de Janeiro, RJ,  
Brazil.

- 28-1 13th International Symposium on  
GaAs and Related Compounds.  
Hilton Head, SC.  
C. M. Wolfe, Washington Univ.,  
Box 1127,  
St. Louis, MO 63130.

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OCTOBER 1986

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- 7-9 18th National SAMPE Technical  
Conference.  
Seattle, WA.  
SAMPE, 843 West Glentana (Box  
2459), Covina, CA 91722; (818)  
331-0616.  
*(See related article in Vol. X No. 5.)*
- 19-24 Fall Meeting of the  
Electrochemical Society.  
San Diego, CA.  
Electrochemical Society,  
10 S. Main St.,  
Pennington, NJ 08534-2896.
- 21-24 Meeting of the Optical Society of  
America.  
Los Angeles, CA.  
OSA, 1816 Jefferson Pl., N.W.,  
Washington, DC 20036.
- 26-31 33rd National Vacuum  
Symposium of the American  
Vacuum Society.  
Baltimore, MD.  
N. Hammond, 335 E. 45th St.,  
New York, NY 10017.

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NOVEMBER 1986

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- 3-7 Meeting of the Division of Plasma  
Physics of the APS.  
Baltimore, MD.  
W. W. Havens, 335 E. 45th St.,  
New York, NY 10017.

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DECEMBER 1986

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- 1-5 **MRS Materials Research  
Society Fall Meeting.**  
Boston, MA.  
J. B. Ballance, Materials Research  
Society, 9800 McKnight Road,  
Suite 327, Pittsburgh, PA 10017.

**MRS**

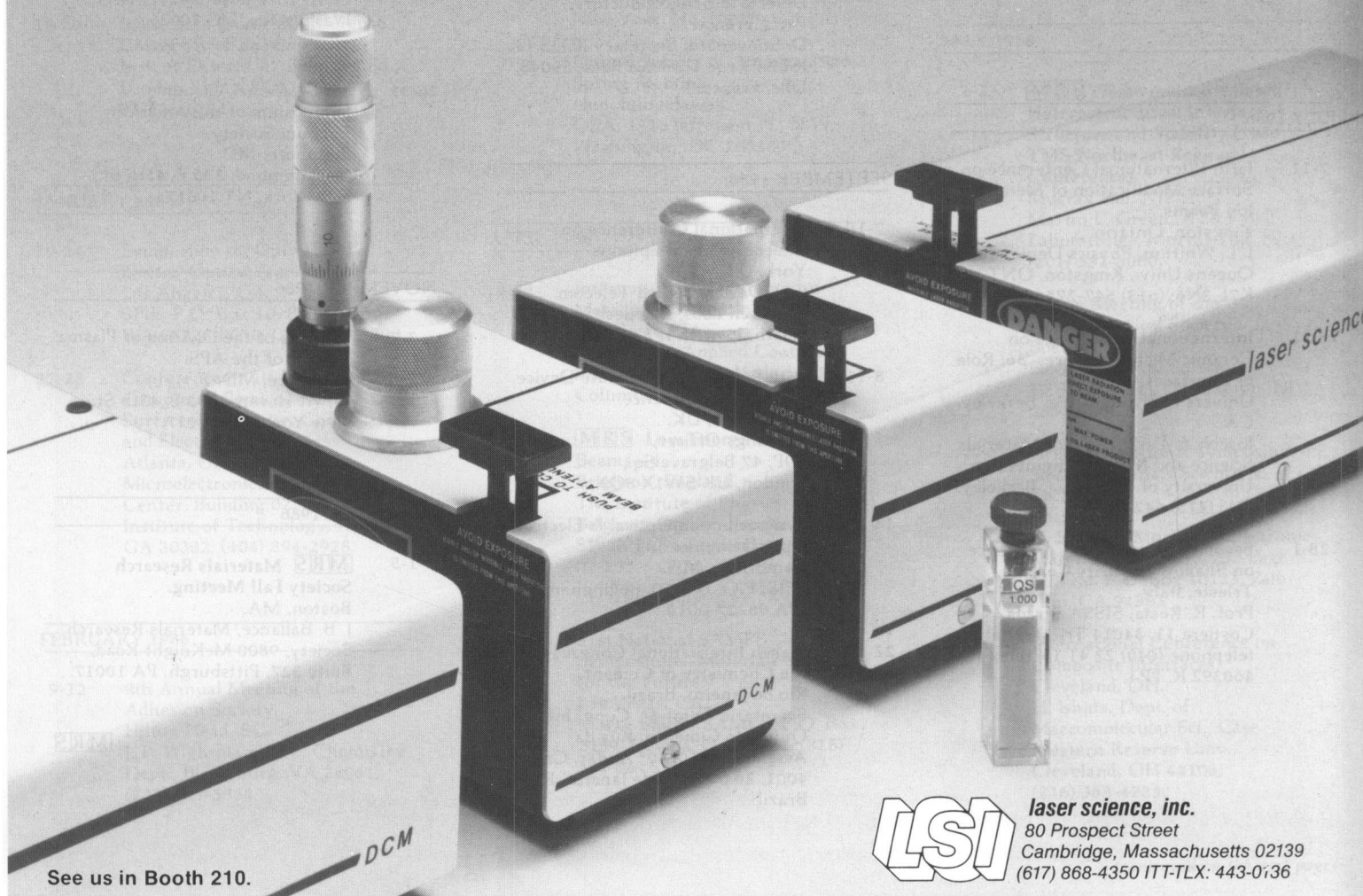
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